

A Trench Gate Reverse-Conducting IGBT with a Shallow Oxide Trench and a Floating P-Region

Cai-Lin Wang, Rong-Hua Cheng, Wu-Hua Yang, Ru-Liang Zhang

Introduction

A Trench Gate Reverse-Conducting IGBT with a shallow oxide trench and a floating p-region (STFP RC-IGBT) is proposed to suppress the snapback phenomenon during the forward conduction. Take 1700 V RC-IGBT for example, the forward, reverse and short-circuit characteristics are analyzed by simulation. The results show that, compared with the conventional RC-IGBT and TFP RC-IGBT, the snapback-free characteristics can be realized in STFP RC-IGBT by cell size of 32 μm . Furthermore, the turn-off energy loss, E_{off} , of IGBT and the reverse recovery peak current density, J_{RM} , of diode are the lowest.

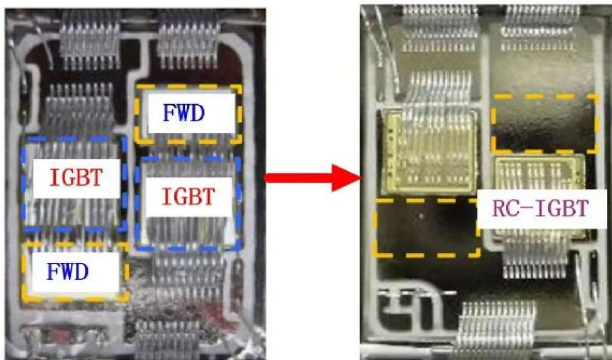


Fig. 1 RC-IGBT

The Conventional RC-IGBT Structure

In practical application circuits, IGBT needs to be connected with the Free Wheeling Diode (FWD) to conduct reverse conduction. Therefore, the RC-IGBT which introduces the n^+ -shorted region at the collector side of the IGBT is proposed, and the resulting advantages and disadvantages can be summarized with the following points:

- The resulting advantages:
Making the chip area, parasitic inductance and the manufacturing cost are greatly reduced, and the power density and reliability of the device are also improved.
- The resulting disadvantages:
Due to the introduction of the n^+ -shorted region, the snapback phenomenon occurs during the forward conduction of the RC-IGBT, which makes it increase the turn-on loss

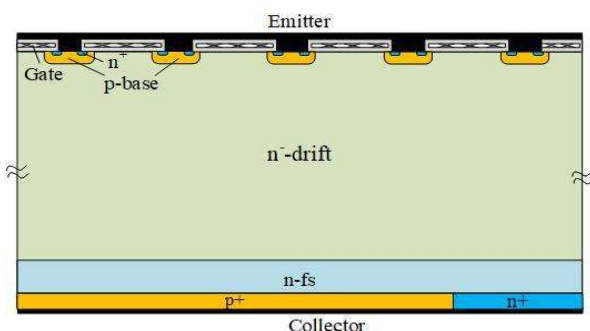


Fig. 2 The conventional RC-IGBT structure

Conclusion

An improved RC-IGBT with a shallow oxide trench and a p-float region is proposed to suppress the snapback phenomenon and reduce process difficulty in this paper. As the simulation results show that, the forward conduction has no snapback phenomenon. In addition, compared with the conventional RC-IGBT and the TFP RC-IGBT, the E_{off} of the STFP RC-IGBT is decreased by 7.2% and 5.5%, respectively, and the J_{RM} of the STFP RC-IGBT is decreased by 10.2% and 27.5%, respectively. In addition, the IGBT of STFP RC-IGBT is still able to turn off 10 μs after the short-circuit occurs.

The TFP RC-IGBT Structure:

Reverse-Conducting IGBT with an oxide trench placed between the n^+ -shorted region and the p^+ collector and a floating p-region sandwiched between the n -drift region and the n^+ -shorted region structure.

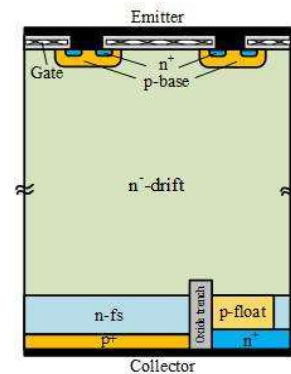


Fig. 3 TFP RC-IGBT structure

And the TFP RC-IGBT increases the collector side short resistor, R_{cs} , by adding oxide trench and p-float region, which suppresses the snapback phenomenon well, but it is difficult to operate the process of deep trench etching and oxide filling.

The STFP RC-IGBT Structure

An improved RC-IGBT with a shallow oxide trench and a p-float region is studied in this paper. And the front of the STFP RC-IGBT adopts the dummy trench which is connected to Emitter and n-carrier storage layer (n -cs), and the ratios of Active Trench Gate (AT) to Dummy Trench (DT) is 1:3, these can obtain lower saturation voltage $V_{\text{CE sat}}$ without damaging the short-circuit ability of IGBT.

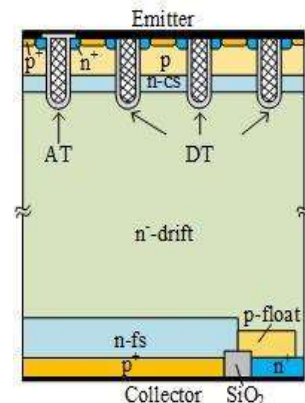


Fig. 4 STFP RC-IGBT Structure

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TCAD Simulation results

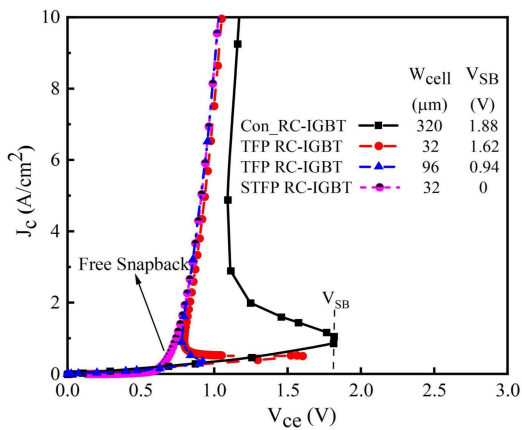


Fig. 4 Forward conduction characteristics of the three types of RC-IGBT

TCAD Simulation results

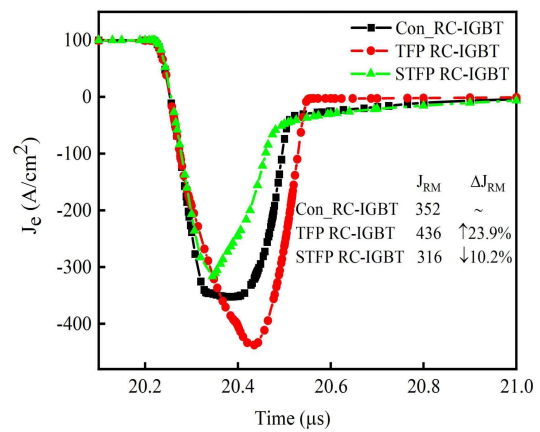


Fig. 7 The diode reverse recovery characteristics of three types of RC-IGBT

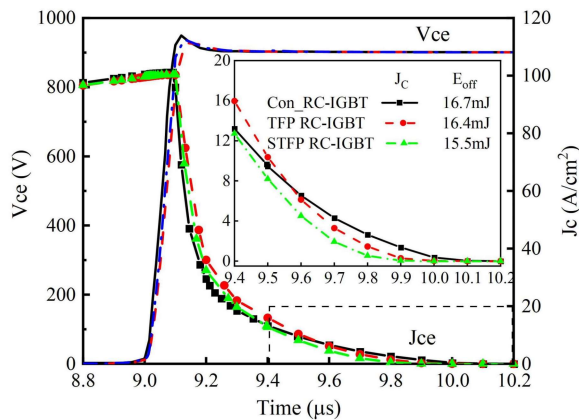


Fig. 5 The IGBT turn-off characteristic of three types of RC-IGBT

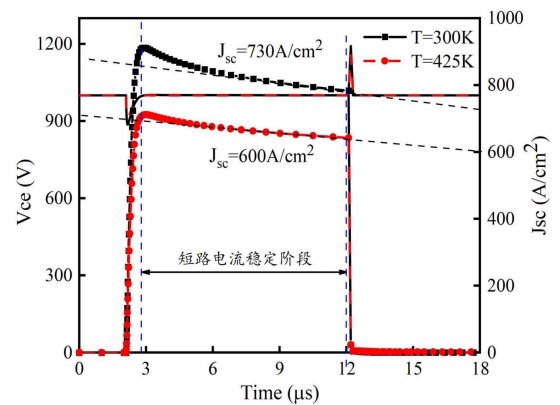


Fig. 8 The short-circuit characteristics of STFP RC-IGBT

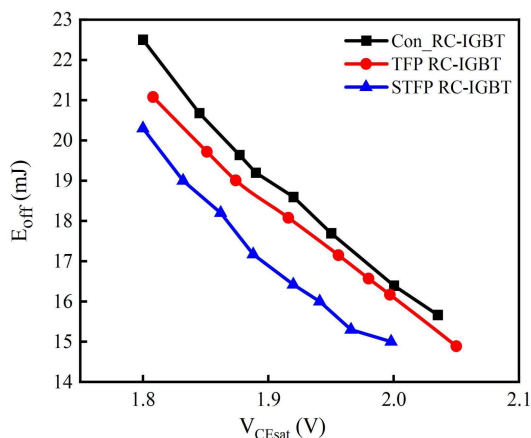


Fig. 6 V_{CEsat} and E_{off} trade-off relations of IGBT of STFP RC-IGBT

Results

STFP RC-IGBT:

- Snapback -free forward conduction characteristic with smaller cell size
- Lower switching energy loss, E_{off} , of IGBT
- Superior V_{CEsat} - E_{off} compromise relationship
- Lower reverse recovery peak current density, J_{RM} , of integrated Diode
- With 10 μs tsc of short-circuit